





IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT:

Akira Yoshizawa, et al.

ATTY. DOCKET NO. 09792909-5237

SERIAL NO.

DATE FILED:

INVENTION:

"SEMICONDUCTOR DEVICE USING INTERPOSER SUBSTRATE AND

MANUFACTURING METHOD THEREFOR"

Assistant Commissioner of Patents

Washington, D.C. 20231

SIR:

Applicants submit this Preliminary Amendment for consideration in the above-identified patent application:

IN THE SPECIFICATION

At page 10, line 16, change "Figs. 4A to 4F" to --Figs. 4A to 4J--.

Respectfully submitted,

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